



#12/A

6-02
Mellish
PATENTCustomer No. 22,852
Attorney Docket No. 08038.0024

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)

Noriaki FUKIAGE)

) Group Art Unit: 2811

Serial No.: 09/657,055)

) Examiner: H. Vu

Filed: September 7, 2000)

For: SEMICONDUCTOR DEVICE AND)
METHOD OF MAKING THE SAME)Assistant Commissioner for Patents
Washington, DC 20231

Sir:

AMENDMENT

In reply to the Office Action dated January 15, 2002, the period for reply having been extended for two months by a request for extension and fee payment filed concurrently herewith, please amend the application as follows:

IN THE TITLE:

Please change the title to read --SEMICONDUCTOR DEVICE HAVING MULTILAYER INTERCONNECTION STRUCTURE AND METHOD OF MAKING THE SAME--.

IN THE SPECIFICATION:

Please amend the paragraph beginning at line 11 of page 1 and ending at line 17 of page 1 as follows:

RECEIVED
JUN - 7 2002
TC 2800 MAIL ROOMFINNEGAN
HENDERSON
FARABOW
GARRETT &
DUNNER LLP1300 I Street, NW
Washington, DC 20005
202.408.4000
Fax 202.408.4400
www.finnegan.com